

<b>Notice of References Cited</b>	Application/Control No. 10/731,289	Applicant(s)/Patent Under Reexamination NIKI ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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**FOREIGN PATENT DOCUMENTS**

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	N	JP 2001310435 A	11-2001	Japan	HASE et al.	B32B031/00
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